

<b>Notice of References Cited</b>	Application/Control No. 09/557,118		Applicant(s)/Patent Under Reexamination CZYSZCZEWSKI ET AL.	
	Examiner David L Jones		Art Unit 2622	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,577,907	06-2003	Czyszczewski et al.	700/17
*	B	US-6,246,487	06-2001	Kobayashi et al.	358/1.13
*	C	US-6,097,797	08-2000	Oseto, Futoshi	379/100.08
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	J	US-			
	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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